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10-046497

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Title of Invention: Method for Forming Raised Structures by Controlled Selective Epitaxial Growth of Facet Using Spacer
First Named Inventor: Er-Xuan Ping
Domestic/Foreign Application: Domestic Application
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TRANSMITTAL FORM

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Submission Type: Information
Disclosure Statement

Application Number: 10/046,497
Attorney Docket Number: MTI-31041-A

Method for Forming Raised Structures by Controlled Selective Epitaxial Growth of Facet Using Spacer

First Named Inventor: Er-Xuan Ping

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Date Signed: 20021003

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Attached Files:

us-information-disclosure-statement

MTI31041Aids.xml

Comments:



Electronic Information Disclosure Statement

Method for Forming Raised Structures by Controlled Selective Epitaxial Growth of Facet Using Spacer

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Application: 
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Applicant(s): Er-Xuan Ping

Docket
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Group Art Unit: 2814


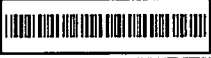


Examiner: Thao X. Le

search string: (5393681 or 6391692 or 5308782 or 5998248 or 6319782 or 4554570 or 5200352 or 5376562 or 5079180 or 5753555).pn.

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Citation No.	Patent Number	Date	Bar Code	Patentee	Class	Subclass
	P01	5393681	1995-02-28		Witek et al.	438	164
	P02	6391692	2002-05-21		Nakamura	438	151
	P03	5308782	1994-05-03		Mazure et al.	438	154
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P09	5079180	1992-01-07		Rodder et al.	438	297
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Signature

Examiner Name	Date
/Thao Le/	11/26/2007